

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: To Be Assigned

Examiner: To Be Assigned

In re PATENT APPLICATION of:

Applicant(s) : Jun KANAMORI

Appln. No. : To Be Assigned

Filed : August 6, 2003

For : SEMICONDUCTOR DEVICE  
FABRICATION METHOD USING  
OXYGEN ION IMPLANTATION

Atty. Dkt. : MAE 292

INFORMATION  
DISCLOSURE  
STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

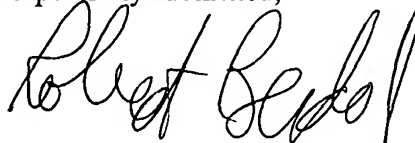
Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(b)(1).

Attached are copies of two Japanese publications. Any relevance of the Japanese publications can be gleaned from the attached English-language Abstracts, and from page 1 of the present application where these documents are discussed. The documents are listed on the attached Form PTO-1449.

Since this Information Disclosure Statement is being filed with the application, no certification or fee is required, and the requirements of 37 C.F.R. §§1.97 and 1.98 are deemed to be fully met as to the document submitted. Consideration of the submitted documents is respectfully requested.

Respectfully submitted,



Robert H. Berdo, Jr. (Reg. No. 38,075)

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August 6, 2003

Date

RHB:tz

<b>FORM PTO-1449</b>  <b>INFORMATION DISCLOSURE STATEMENT</b>				Atty Docket		Application No.	
				<b>MAE 292</b>		<b>To Be Assigned</b>	
				Applicant			
				<b>Jun KANAMORI</b>			
				Filing Date		Group Unit	
				<b>August 6, 2003</b>		<b>To Be Assigned</b>	
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
<b>FOREIGN PATENT DOCUMENTS</b>							
		Document Number	Date	Country	Class	Sub-Class	Trans-lation
	AH	07-022504	01/24/95				<b>Abstract</b>
	AI	06-310534	11/04/94				<b>Abstract</b>
	AJ						
	AK						
	AL						
	AM						
	AN						
<b>OTHER (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AO						
	AP						
	AQ						
	AR						
Examiner					Date Considered		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							